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Substitute for form 1449/PTO  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  <i>(Use as many sheets as necessary)</i>		<b>Complete if Known</b>	
		Application Number	
		Filing Date	
		First Named Inventor	David J. Christie
		Art Unit	
		Examiner Name	
Sheet 2	of 3	Attorney Docket Number	AE2002-006CIP

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
	1	JUNQING LU et al; Sep/Oct 2001, pp.. 2652-2663	
		Trench filling by ionized metal physical vapor deposition;	
	2	VLADIMIR KOUZNETSOV et al., Surface and Coatings Technology 122 (1999); pp. 290-293	
		A Novel Pulsed Magnetron Sputter Technique Utilizing Very High Target Power Densities	
	3	KAROL MACAK et al., Jul/Aug 2000; pp. 1533 - 1537	
		Ionized Sputter Deposition Using an Extremely High Plasma Density Pulsed Magnetron Discharge	
	4	J.T. GUDMUNDSSON et al., May 28, 2001, Volume 78, Number 22; pp. 3427-3429	
		Evolution of the Electron Energy Distribution and Plasma Parameters in a Pulsed Magnetron Discharge	
	5	A.P. EHIASARIAN et al., Vacuum 65 (2002); pp. 147-154	
		Influence of High Power Densities on the Composition of Pulsed Magnetron Plasmas	

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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> Applicant is to place a check mark here if English language Translation is attached.

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	6	OTHON R. MONTEIRO, May/Jun 1999; pp. 1094-1097	
		Novel Metallization Technique for Filling 100-nm-wide Trenches and Vias with Very High Aspect Ratio	

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David J. Christie

Art Unit

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Sheet

1

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## U. S. PATENT DOCUMENTS

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